

**Notice of References Cited**

Application/Control No.

10/532,255

Applicant(s)/Patent Under  
Reexamination  
ARNOLD ET AL.

Examiner

Chen-Wen Jiang

Art Unit

3744

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0055578 A1	05-2002	Wu et al.	524/445
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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